REQUEST FOR Application Number 097528,296 **CONTINUED EXAMINATION (RCE)** Filing Date March 17, 2000 **TRANSMITTAL** First Named Inventor Kazuhiko TAKADA Subsection (b) 35 U.S.C. § 132, effective on May 29, 2000, provides for the continued examination of a utility or plant application filed on or after June 8, 1995. Group Art Unit 2811 FEB 1 9 2002 Name of Examiner Ori NADAV Attorney Docket No. 000294

This is a Request for Continued Examination (RCE) under 37 C.F.R. § 1.114 of the above-identified application.

Note: 37 C.F.R. § 1.114 is effective on May 29, 2000. If the above-identified application was filed prior to May 29, 2000, applicant may wish to consider filing a continued prosecution application (CPA) under 37 C.F.R. §1.53 (PTO/SB/29) instead of a RCE to be eligible for the patent term adjustment provisions of the AIPA. See changes to Application Examination and Provisional Application Practice, Interim Rule, 65 Fed. Reg. 14865 (Mar 20, 2000) 1233 Off. Gazette Pat Office (April 11, 2000) which established RCE practice.

1.	Submission Required Under 37 C.F.R. § 1.114			
a.	☐ Previously submitted			
	i. Consider the amendment(s)/reply under 37 C.F.R. §1.116 previously filed on			
	ii. Consider the arguments in the Appeal Brief or Reply Brief previously filed on			
	iii. Other	RECEIVED FEB 22 2002 TECHNOLOGY CENTER 2800		
b.	⊠ Enclosed	ECEIVED FEB 22 2002		
	i. Amendment (Preliminary)	2		
	ii.			
	iii. Information Disclosure Statement (IDS)	280		
	iv. Other	6		
2.	Miscellaneous			
a.	Suspension of Action on the above-identified application is requested under 37 C.F.R. §1.103(c) for a period of months (period shall not exceed three months; Fee under 37 C.F.R. §1.17(i) required)			
b.				
3. Fees The RCE fee under 37 C.F.R. §1.17(e) is required by 37 C.F.R. §1.114 when the RCE is filed.				
a.	☐ The Commissioner is hereby authorized to charge the following fees, or credit any overpayments.	, to Deposit Account No.		
	i. ⊠ RCE fee required under 37 C.F.R. § 1.17 (e)			
	ii. Extension of Time Fee (37 C.F.R. §§ 1.136 and 1.17)			
	iii. Other			
b				

REQUEST FOR CONTINUED EXAMINATION (RCE) TRANSMITTAL

Subsection (b) of 35 U.S.C. § 132, effective on May 29, 2000, provides for the continued examination of a utility or plant application filed on or after June 8, 1995.

PAGE 2

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Atty Docket No.

000294

SIGNATURE BY APPLICANT. ATTORNEY. OR AGENT REOUIRED		
Name	Joseph L. Felber	Registration No. 48,109
Signature	Joseph L. Seller	Date January 19, 2002
	CERTIFICATE OF M	MAILING OR TRANSMISSION
I hereby cer addressed to Office on:	tify that this correspondence is being deposited wito Commissioner for Patents, BOX RCE, Washington	h the United States Postal Service as first class mail in an envelope on, D.C. 20231, or facsimile transmitted to the U.S. Patent and Trademark
addressed to	tify that this correspondence is being deposited wito Commissioner for Patents, BOX RCE, Washingto	h the United States Postal Service as first class mail in an envelope on, D.C. 20231, or facsimile transmitted to the U.S. Patent and Trademark

REQUEST FOR CONTINUED EXAMINATION (RCE) TRANSMITTAL

Subsection (1) of 35 U.S.C. § 132, effective on May 29, 2000, provides for the continued examination of a utility or plant application filed on or after June 8, 1995.

FEB 1 9 2002 3

Application Number	09/528,296	
Filing Date	March 17, 2000	
First Named Inventor	Kazuhiko TAKADA	
Group Art Unit	2811	
Name of Examiner	Ori NADAV	
Attorney Docket No.	000294	

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Note: 37 C.F.R. § 1.114 is effective on May 29, 2000. If the above-identified application was filed prior to May 29, 2000, applicant may wish to consider filing a continued prosecution application (CPA) under 37 C.F.R. § 1.53 (PTO/SB/29) instead of a RCE to be eligible for the patent term adjustment provisions of the AIPA. See changes to Application Examination and Provisional Application Practice, Interim Rule, 65 Fed. Reg. 14865 (Mar 20, 2000) 1233 Off. Gazette Pat Office (April 11, 2000) which established RCE practice.

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b.	Other				
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a.	a. The Commissioner is hereby authorized to charge the following fees, or credit any overpayments, to Deposit Account No.				
	i. ⊠ RCE fee required under 37 C.F.R. § 1.17 (e)				
	ii.				
	iii.				
Ъ.	☐ Check in the amount of \$ 740.00 is enclosed.				

REQUEST FCC CONTINUED EXAMINATION (RCE) TRANSMITTAL

Subsection (h) of 35 U.S.C. § 132, effective on May 29, 2000, provides for the continued examination of a utility or plant application filed on or after June 8, 1995.

PAGE 2

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SIGNATURE BY APPLICANT. ATTORNEY, OR AGENT REOUIRED			
Name	Joseph L. Felber		Registration No. 48,109
Signature	Joseph L.	Feller	Date January 19, 2002
		CERTIFICATE O	F MAILING OR TRANSMISSION
I herebycer addressed to Office on	rtify that this correspond o Commissioner for Pate	ence is being deposited nts, BOX RCE, Washi	l with the United States Postal Service as first class mail in an envelope ngton, D.C. 20231, or facsimile transmitted to the U.S. Patent and Trademark
Name			
Signature			



#121B 3.1-02 Hayes

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Kazuhiko TAKADA

Serial No.: 09/528,296

Group Art Unit: 2811

Filed: March 17, 2000

Examiner: Ori NAVAV

For: SEMICONDUCTOR DEVICE HAVING A GUARD RING

PRELIMINARY AMENDMENT AND REQUEST FOR INTERVIEW

Commissioner for Patents Washington, D.C. 20231

Date: February 19, 2002

Sir:

Please amend the above-identified application as follows:

IN THE CLAIMS:

Amend the claims 1 and 6 as follows:

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1. (Twice Amended) A semiconductor device, comprising:

a substrate; and

a multilayer interconnection structure formed on said substrate,

said multilayer interconnection structure including: at least first and second interlayer insulation films provided on said substrate; and a guard ring pattern embedded in each of said first and second interlayer insulation films, said guard ring pattern extending along a periphery of said substrate, said multilayer interconnection structure being planarized by using a CMP process,